

Freestanding Polymer MEMS Structures with Anti Stiction

Abstract of Disclosure

An anti stiction structure for cantilever formation technique. In one embodiment, the polymer cantilever is prevented from sticking to the substrate by at amortized stick layer on the substrate during formation that is later removed as a sacrificial layer. In another embodiment, the cantilever includes downwardly extending legs.

TOP SECRET

Figures

[illegible]